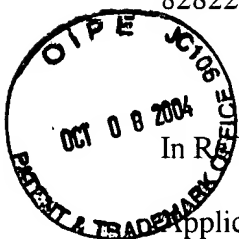


82822

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant: Kozo Nakamura

Serial No.: 09/856,209

Filed: May 18, 2001

For: **SILICON CRYSTAL AND
PRODUCTION METHOD FOR
SILICON SINGLE CRYSTAL
WAFER**

Examiner: Matthew J. Song

) Art Unit: 1765

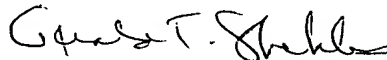
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) *Gerald T. Shekleton Reg. No. 27,466*

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AMENDMENT

Mail Stop AMENDMENT
Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

Sir:

The Office Action of July 9, 2004 has been carefully reviewed and the following
amendments and remarks are made in response thereto.